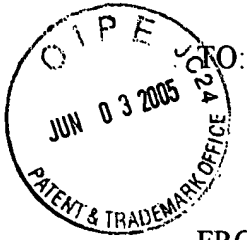


IFW



Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

FROM: George O. Saile, Reg. No. 19,572
28 Davis Ave.
Poughkeepsie, N. Y. 12603


SUBJECT: Serial #: 10/761,003
File Date: 01/20/04
Inventor: Tai Min
Examiner: Erdem, Fazli
Art Unit: 2826
Title: Magnetic Tunneling Junction Film Structure
With Process Determined In-Plane Magnetic
Anisotropy

RESPONSE TO OFFICE ACTION

This is in response to the office action dated 02/28/2005. Please amend the
above identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents P. O. Box 1450, Alexandria, VA 22313-1450, on:

May 31, 2005
Signature  5/31/05
Stephen B. Ackerman, Reg. No. 37,761

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.